



Attorney's Docket No.: 05542-459003 / 5353C1/CMP

OP 1763

✓ [Signature]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Wallace T.Y. Tang
Serial No. : 09/134,147
Filed : August 14, 1998
Title : IN-SITU REAL-TIME MONITORING TECHNIQUE AND APPARATUS FOR
DETECTION OF THIN FILMS DURING CHEMICAL/MECHANICAL
POLISHING PLANARIZATION

Art Unit : 1763
Examiner : Sylvia R. MacArthur

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO ACTION OF AUGUST 12, 2004

Reconsideration is respectfully requested in view of the following remarks.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

November 12, 2004

Date of Deposit

[Signature]

Signature

Carlos A. Brasil

Typed or Printed Name of Person Signing Certificate